EV257330089US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: James P. Baukus, et al.) Re: Information Disclosure

Statement

Serial No.: Not yet assigned
Filed: concurrently herewith

Divisional of USSN 09/882,900
filed on June 15, 2001

For: "PROGRAMMABLE CONNECTOR/
ISOLATOR AND DOUBLE POLYSILICON
LAYER CMOS PROCESS WITH BURIED

CONTACT USING THE SAME"

) Re: Information Disclosure

Statement

)

Our Ref: B-3947DIV 621039-4

)

Date: July 14, 2003

Mail Stop Patent Application Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the Applicant's duty to disclose information which may be material to the examination of this application, the undersigned respectfully requests that the documents cited by the Examiner and/or submitted by the Applicant in connection with U.S. Serial No. 09/882,900 filed on June 15, 2001 (the parent of the Applicants' subject application) be considered by the Examiner before issuing the first Office Action on the merits.

For the Examiner's convenience, Form PTO-1449 (modified) is enclosed herewith listing the documents cited by the Examiner and/or submitted by the Applicant in connection with U.S. Serial No. 09/882,900.

The filing of this Information Disclosure Statement (IDS) shall not be construed as a representation that a search has been made (37 C.F.R. 1.97(g)), an admission that the information cited is, or is considered to be, material to patentability, or that no other material information exists.

If any fees are due, please charge our Deposit Account No. 12-0415 or credit any overpayment to our Account No. 12-0415. No fees should be due because this Information Disclosure Statement is being filed concurrently with the above-identified U.S. patent application.

The filing of this Information Disclosure Statement shall not be construed as an admission against interest in any manner. (Notice of January 9, 1992, 1135 O.G. 13-25, at 25.)

The person making this statement is the practitioner who signs below on the basis of information supplied by an individual associated with the filing and prosecution of this application (37 C.F.R. § 1.56(c)) and on the basis of information in the practitioner's file.

Respectfully submitted,

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Enclosures: Form PTO-1449 (modified) (6 pages)

Form PTO-1449 (Modified)	ATTY DOCKET NO. B-3947DIV 621039-4	<pre>U.S. SERIAL NO. not yet assigned</pre>	
LIST OF PATENTS AND PUBLICATIONS STATEMENT	APPLICANT(S) James P. Baukus, et al.		
	FILING DATE concurrently herewith	GROUP not yet assigned	

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EXAMINER	DATE CONSIDERED
ANTARD. Talkial 16 means and days	

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.